

Application No. 10/568,727

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 100191CIP)

First Inventor: Nam, Chul Woo

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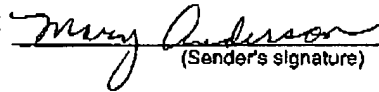
Title: CHEMICAL-MECHANICAL
POLISHING COMPOSITION AND
METHOD FOR USING THE
SAME

Examiner: Vinh. Lan

Art Unit: 1792

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i, Mary Anderson, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted by facsimile to the US Patent and Trademark Office's central fax No. (571) 273-8300 on 02 OCT 2009.


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RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir,

This paper is submitted in response to the Office Action mailed July 2, 2009. Please consider the following remarks and enter the following amendments in the record for this application.

Amendments to the Claims are reflected in the listing of claims, and begin on page 2 of this paper.

Remarks begin on page 5 of this paper.